

Testing and Qualification of EP Thrusters at the FOTEC Propulsion Laboratories

Bernhard Seifert FOTEC Forschungs- und Technologietransfer GmbH

EPIC Workshop, London, UK 15-17 October 2018

Company Overview





University of Applied Sciences Wiener Neustadt

- Founded in 1994
- 34 bachelor / master programs
- 3500 students





Subsidiary

FOTEC Forschungs- und Technologietransfer GmbH

- Research subsidiary, carrying out R&D Projects with industry. Owned by University.
- 30+ years of experience manufacturing flight hardware for scientific missions (ESA, NASA, ...)







The IFM Nano Thruster Module

Key Characteristics

- Dynamic Thrust Range: 1 to 350 μN , nominal: 300 μN
- Specific Impulse: 2,000 to 7,000 s
- Propellant mass: up to 250 g Indium
- Total Impulse: more than 5,000 Ns
- Outer dimensions: 94 x 90 x 78 mm
- System mass: 620 g (dry), 870 g (wet)

PPU Features

- Emitter: up to 10 kV, up to 4 mA
- Extractor: down to -10 kV, down to -500 μA
- Heater: up to 8 V, up to 3 A
- Neutralizer filament heater: up to 5 W, two selectable filaments
- Neutralizer bias: -200 V
- Contactless temperature measurement

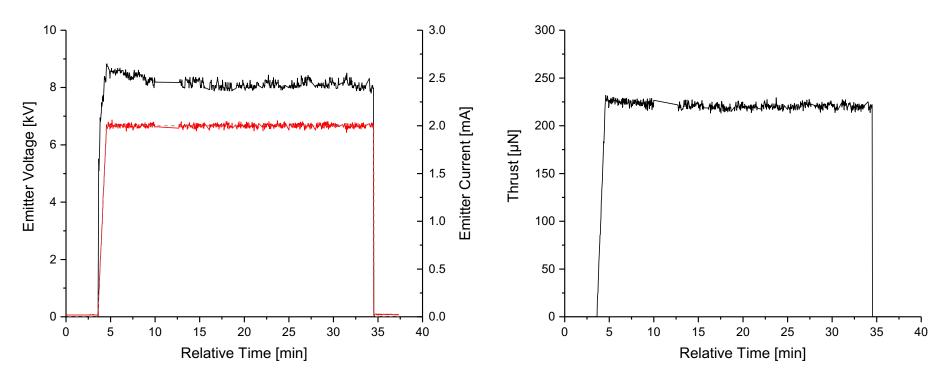


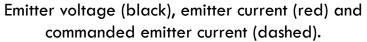


In-Orbit Demonstration

Fortec Cristian States Fortungsunternehmen der Fil Wiener Neustadt-

- Continuous operation for 30 minutes at 2 mA emitter current
- Good accordance between reference and measured current





In-Orbit Demonstration (cont'd)



Test Summary

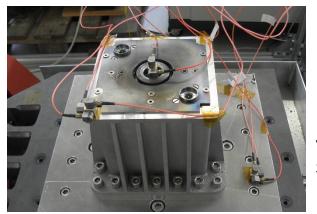
- Internal thrust computation: 226 μ N (begin) to 220 μ N (end)
- Very stable operation
- Spacecraft attitude could not be maintained for the whole period (wheels saturation)

Orbital Change

- Expected $\Delta v: 6.68 \text{ cm/s}$ (considering cosine losses)
- Expected orbit raise: 115 m
- Verified orbit raise (GPS data with 50x50 Earth gravity field model): 116 \pm 5 m/s
- Excellent accordance between predicted and confirmed orbit raise

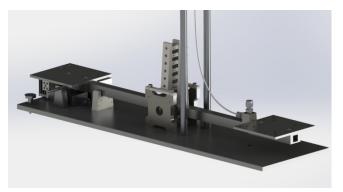
In-house Electric Propulsion Testing Facilities





Thrust balance development 0.1 µN to 100 mN Verified at EPL/ESTEC

Vibration Testing Shock Testing





Plume characterization 23 Faraday cups QCM and RPA measurements Large chamber: 2.5m Ø, 4m length

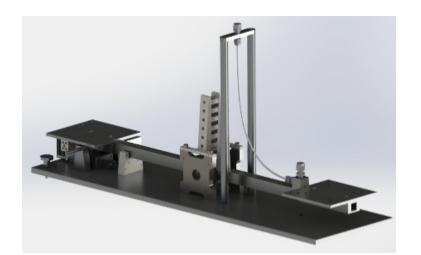
Thermal Shroud -60 to + 90°C 2x1x1m usable volume Vacuum pressure < 10⁻⁶ mbar

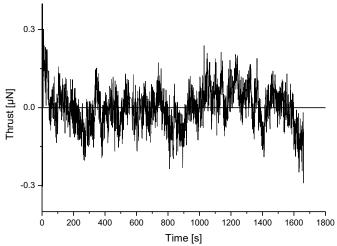


µN to mN Thrust Balance



- Horizonal deflection balance suspended by spring bearings
- Developed for electric propulsion and cold gas thrusters
- Gas and friction-less electric feed-throughs
- Thrust range: 0.1 μN to 100 mN
- Force-feedback control with electrostatic and electromagnetic force actuators
- Low thrust noise: $< 0.15 \ \mu N_{RMS}$ (range: 500 μN)
- Low drift rate: $< 2 \mu N/h$ (range: 500 μN)
- Verified at ESTEC/EPL with MOOG cold gas thruster





Vibration and Shock Testing



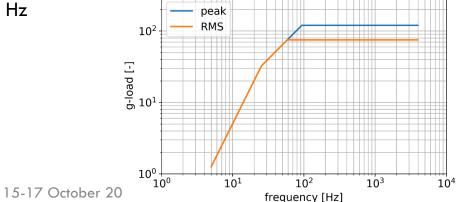
Shaker

- Rated sinusoidal force: 8896 N
- Rated random force: 5782 N
- Usable frequency range: 5 4000 Hz
- Maximum displacement amplitude: 25.4 mm
- Rated peak velocity: 2.0 m/s
- Maximum acceleration:
 - 120 g peak —
 - 75 g RMS
- Maximum payload mass (vertical operation): 160 kg
- Fundamental armature resonance: 3000 Hz

Shock table

Shock response up to 1024 g ۲





Plume Characterization

Faraday cups and RPAs

- Plume characterization with:
 - Langmuir probes
 - planar probes
 - Faraday cups
 - Retarding Potential Analyzer (RPA)
- In-house design of Faraday cup and RPA optimized for LMIS
- Design based on numerical simulations and experimental verification
- Specifically designed for low electron density plasma fields
- Probes mounted on a remotely controlled boom allowing scans of a whole hemisphere





Update rate up to 7 Hz

Segmented collector

250 planar probes

Plume Characterization (cont'd)

Real-time monitoring of beam divergence and deflection

Thrust angle: 24.06°

Thrust angle: 15.14°





5 needles firing Emitter: 12 kV / 1 mA Extractor: -5 kV

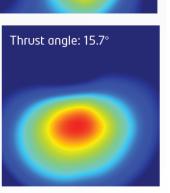


14 needles firing Emitter: 18 kV / 6 mA Extractor: -5 kV



OPERATING CONDITIONS





MEASUREMENT



Vacuum pressure: < 10⁻⁶ mbar

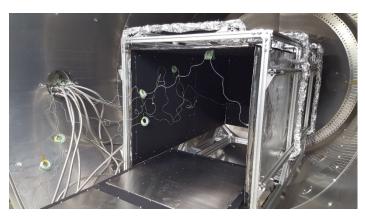
Volume: 2x1x1m

- Removable process plate for DUT mounting
- Individually controllable process and shroud
- Process plate: -40 to +90 °C
- Shroud: -60 to +90 °C
- Temperature ramp: up to 15 °C/h
- Interior covered with vacuum-compatible high-emissivity coating
- Scripted temperature ramps and DAQ













Thank You for your Attention!